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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KOCIMSKI, STANISLAW M.

Group Art Unit: 8617

Serial No.:

Examiner: Bryan Bui

Filed:

May 31, 2001

For:

METHOD OF CHARACTERIZING A SEMICONDUCTOR SURFACE

Docket: 528.015

AMENDMENT AND REPLY

Mail Stop Amendment Commissioner for Patents P O Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the May 5, 2003, Office Action, please amend the above-identified application as follows:

10/17/2003 EAREGAY1 00000012 09871287

01 FC:1201 02 FC:1202

258.00 OP 162.00 OP